

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Michihiro MIZUNO

Serial No.: 09/937,538

Filed: September 25, 2001

For: METHOD FOR EVALUATING  
CONCENTRATION OF  
METALLIC IMPURITIES IN  
SILICON WAFER

Art Unit: 1743

Examiner: Siefke, Samuel P.

Confirmation No. 2057

I hereby certify that this correspondence  
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Mail Stop Issue Fee  
Commissioner for Patents  
P. O. Box 1450,  
Alexandria, VA 22313-1450 on

November 4, 2004

Date of Deposit

Firoozeh Vakilzadeh

Name

 11/4/04

Signature

Date

COMMENTS ON STATEMENT OF REASONS  
FOR ALLOWANCE

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant has received a Notice of Allowance and fee due, which is dated September 15, 2004. The Notice of Allowance is accompanied by a Notice of Allowability.

On page 2 of the Notice of Allowability there is a Statement of Reasons for Allowance. In the first paragraph thereof, it is stated that the reasons for allowance can be found in the last Office Action dated "6/2/07".

Applicant wishes to note for the records that the date of the last Office Action is 6/2/2004 and not 6/2/2007.

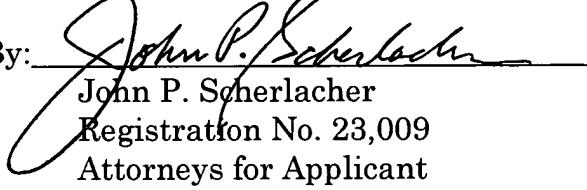
Appl. No. 09/937,538

PATENT  
Attorney Docket No. 81839.0102  
Customer No. 26021

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: November 4, 2004

By:   
John P. Scherlacher  
Registration No. 23,009  
Attorneys for Applicant

500 South Grand Avenue, Suite 1900  
Los Angeles, California 90071  
Phone: 213-337-6700  
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PATENT  
81839.0102

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Firoozeh Vakilzadeh  
Name  
Signature 11/4/04  
Date

**TRANSMITTAL OF ISSUE FEE**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Allowance dated September 15, 2004, enclosed  
are the following:

- Form Part B - Issue Fee Transmittal and a check in the amount of  
\$ 1,676.00 in payment of the Issue Fee, Publication Fee and Advance  
Order for 2 patent copies (at \$3.00 per copy).
- Comments on Statement of Reasons for Allowance.

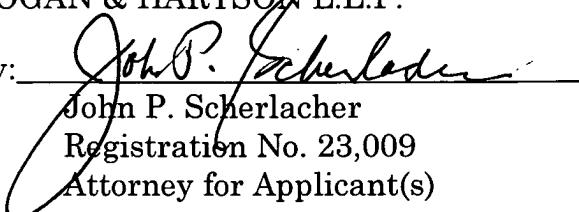
The Commissioner is hereby authorized to charge any deficiency in payment or credit any overpayment to Deposit Account No. 50-1314. A copy of this Transmittal is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: November 4, 2004

By:

  
John P. Scherlacher  
Registration No. 23,009  
Attorney for Applicant(s)

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Los Angeles, California 90071  
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